

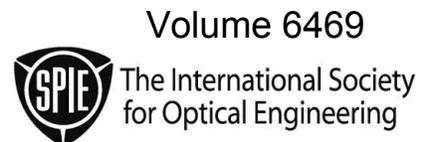
PROCEEDINGS OF SPIE

# ***Optical Components and Materials IV***

**Shibin Jiang**  
**Michel J. F. Digonnet**  
*Editors*

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